## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Docket No.: TI-28996.1

Hogan et al.

Art Unit:

3742

Appln. No.:

10/635,824

Examiner:

Van, Q.

Filed:

08/06/2003

Conf. No.:

7653

For:

Method for Improving Ash Rate Uniformity in Photoresist Ashing Process

Equipment

## ELECTION

April 7, 2004

**Commissioner for Patents** 

P.O. Box 1450

Alexandria, VA 22313-1450

MAILING CERTIFICATE UNDER 37 C.F.R. §1.8(A) I hereby certify that the above correspondence is

being deposited with the U.S. Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

Sue Short

## Examiner:

In response to the Office Action mailed March 31, 2004, Applicants hereby elect to pursue Group I: Claims 1-12 in the above-referenced application.

Respectfully submitted,

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